

Docket No. 740756-2713  
Application No. 10/774,432  
Page 5

### REMARKS

By way of the present response, claims 17, 19, 23 and 25 are amended. Claims 17-28 currently are pending. In view of the above amendments and the remarks advanced below, Applicants respectfully request reconsideration and withdrawal of the rejections of the claims.

In the Office Action, starting in section 3 on page 2, claims 17, 19, 23 and 25 are rejected under 35 U.S.C. § 103 as allegedly being obvious over Yamazaki et al. (U.S. Patent Publication No. 2001/0006827, hereinafter, "the '827 publication"). Insofar as the Office may consider this rejection to apply to the amended claims, Applicants respectfully traverse.

As recited in amended claim 17, a method comprises depositing a film over a substrate by repeatedly moving an evaporation source in an X direction *while* moving the substrate in a Y direction at regular intervals. Support for the amendment is found throughout Applicants' original disclosure, for example, in lines 16-17 of page 9. Similar features are recited in amended claim 23 with respect to depositing an EL material. The Examiner contends that the '827 publication describes moving an evaporation source in a first direction and moving the substrate in a second direction perpendicular to the one direction. However, the '827 publication discloses that a substrate is lastly conveyed after all film formation (see, paragraph 0040).

Consequently, the '827 publication does not teach or suggest the combination including moving an evaporation source in an X direction *while* moving the substrate in a Y direction at regular intervals, as set forth in claims 17 and 23. For similar reasons, the '827 publication does not teach or suggest the combinations of features recited in claims 19 and 25, which recite, among other features, depositing a film or an EL material, respectively, "over a substrate by repeatedly moving the substrate in a Y direction at regular intervals *while* making a movement speed of a first evaporation source in an X direction and a movement speed of a second evaporation source in the X direction different." Accordingly, it is respectfully submitted that claims 19 and 25 are not suggested by the '827 publication.

The Office Action also includes a rejection of claims 18, 20, 21, 22, 24, 26, 27 and 28 under 35 U.S.C. § 103 as allegedly being obvious over the '827 publication in view of Yamazaki et al. (U.S. Patent Publication No. 2002/0187567, hereinafter, "the '567 publication"). This rejection is respectfully traversed, as there is no motivation in the '827

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Docket No. 740756-2713  
Application No. 10/774,432  
Page 6

and '567 publications that would have led one of ordinary skill in the art to combine the two references as suggested in the Action. Furthermore, even if one were to consider, for the sake of argument, that one of ordinary skill in the art would have somehow combined these documents, such a combination would not have resulted in the presently claimed invention.

First, the method of depositing an EL film in the '567 publication relied upon in the Action involves spraying a liquid and not an evaporation source as claimed. Hence, one of ordinary skill in the art would not have looked to the techniques described in the '567 publication to modify an EL film evaporation method of the '827 publication, as proposed by the Examiner, because they involve distinctly different technologies.

Additionally, the '827 publication discloses moving a substrate in an X or Y direction in a step of spraying an EL material to the substrate but does not disclose moving the substrate in the step of evaporating an EL material as claimed. Also, with reference to paragraph 0056 of the '567 publication, spraying is performed either by moving a substrate in the X direction or in the Y direction, or fixing the substrate and scanning the nozzle in the in the X direction or in the Y direction. The '567 publication does not, however, disclose moving the nozzle while moving the substrate. Hence, even if one were to consider *arguendo* combining the teachings of the '827 and '567 publications as proposed, such hypothetical combination would not have taught or suggested moving the nozzle while moving the substrate.

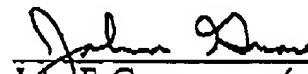
For at least these reasons, it is respectfully submitted that the '827 publication would not have suggested to one of ordinary skill in the art the claimed subject matter, even if it is combined with the '567 publication. The rejections under Section 103, therefore, fail to establish a *prima facie* case of obviousness with respect to independent claims 17, 19, 23 and 25, and hence also the claims which depending from them.

W639922.1

Docket No. 740756-2713  
Application No. 10/774,432  
Page 7

In view of the foregoing, it is respectfully submitted that all pending claims are allowable over the '827 publication and the '567 publication, whether considered individually or in combination. Reconsideration and withdrawal of the rejections is requested.

Respectfully submitted,



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